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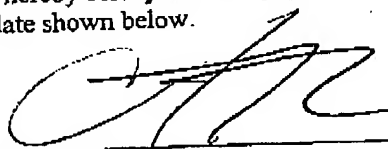
CLIENT/MATTER 9792909-5787

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Type of Paper transmitted: Amendment Under 37 C.F.R. § 1.111

Applicant's Name: Fumikatsu UESAWA

Serial No. (Control No.): 10/720,851

Examiner: Stephen W. Smoot

Filing Date

November 24, 2003

Art Unit: 2813

Application Title:

METHOD OF MANUFACTURING A SEMICONDUCTOR
APPARATUS WITH A TAPERED APERTURE PATTERN TO FORM
A PREDETERMINED LINE WIDTH

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Fumikatsu UESAWA

Group Art Unit: 2813

Application No.: 10/720,851

Examiner: Stephen W. Smoot

Filed: November 24, 2003

Confirmation No.: 5189

For: METHOD OF MANUFACTURING A SEMICONDUCTOR APPARATUS
WITH A TAPERED APERTURE PATTERN TO FORM A PREDETERMINED
LINE WIDTH

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

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AMENDMENT UNDER 37 C.F.R. § 1.111

Sir:

In response to the Office Action dated June 29, 2004, please amend the
above-identified application as follows.